



The growth and characteristics of low-temperature germanium on $\text{Si}_x\text{Ge}_{1-x}\langle 111 \rangle$ and coupling with microdisk

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Introduction

Si-based light-emitting materials are fundamental in optoelectronic integration. However, silicon has an indirect band gap, which makes it difficult to produce effective luminescence at room temperature. A lot of work has been done^{[1][2]}. The indirect band gap characteristics of germanium are determined by its diamond structure. Many researchers have found that germanium has a hexagonal structure, in which the L-valley of Germanium is folded into the position of Γ -Valley (k space), making it a direct band gap.

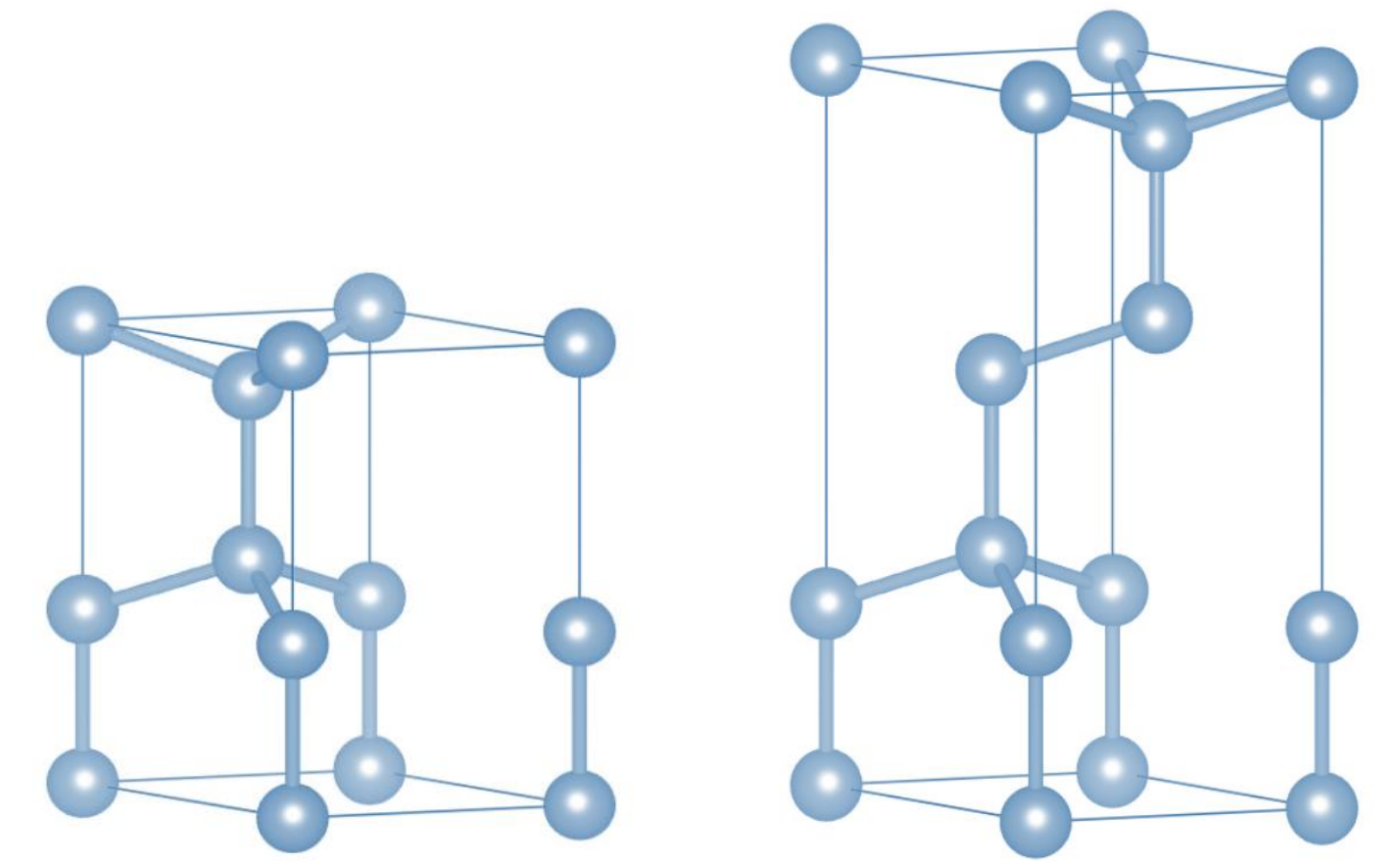


Figure 1. The hexagonal structure(left) and diamond structure(right).

Results

- Nanosphere lithography was used. The $\text{Si}\langle 111 \rangle$ crystal surface was prepared on $\text{Si}\langle 100 \rangle$ substrate.
- Use different sizes of PS balls, and control the thinning time, to control the size and period.

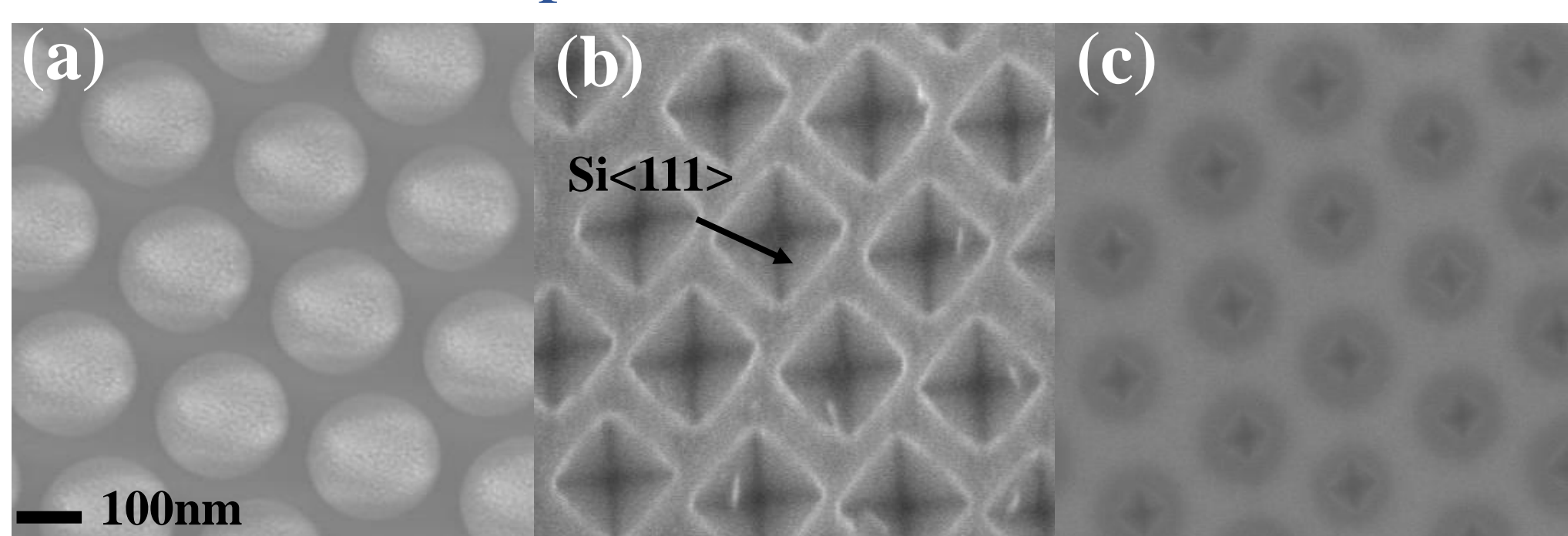


Figure 2. (a) SEM image of PS on $\text{Si}\langle 100 \rangle$. (b)(c) RIE oxygen etching was used to thin the pellets. Using KOH selective etching, the exposed $\text{Si}\langle 111 \rangle$ was obtained.

- The sample was prepared by molecular beam epitaxy(MBE) equipment.
- Information about the microdisk has been reported^[3].

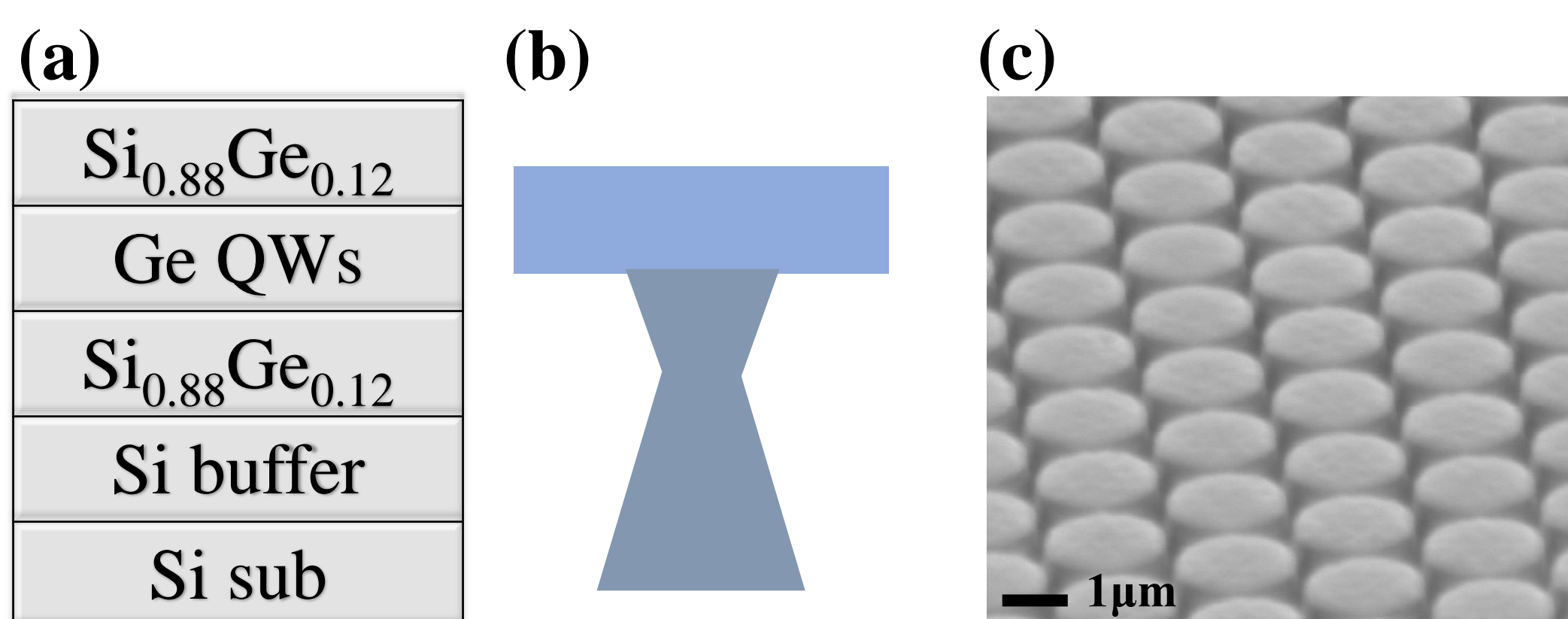


Figure 3. (a) Diagram of sample. (b)(c) Diagram of a microdisk(side view) and SEM of a microdisk array.

- The surface morphology was characterized by atomic force microscope (AFM).

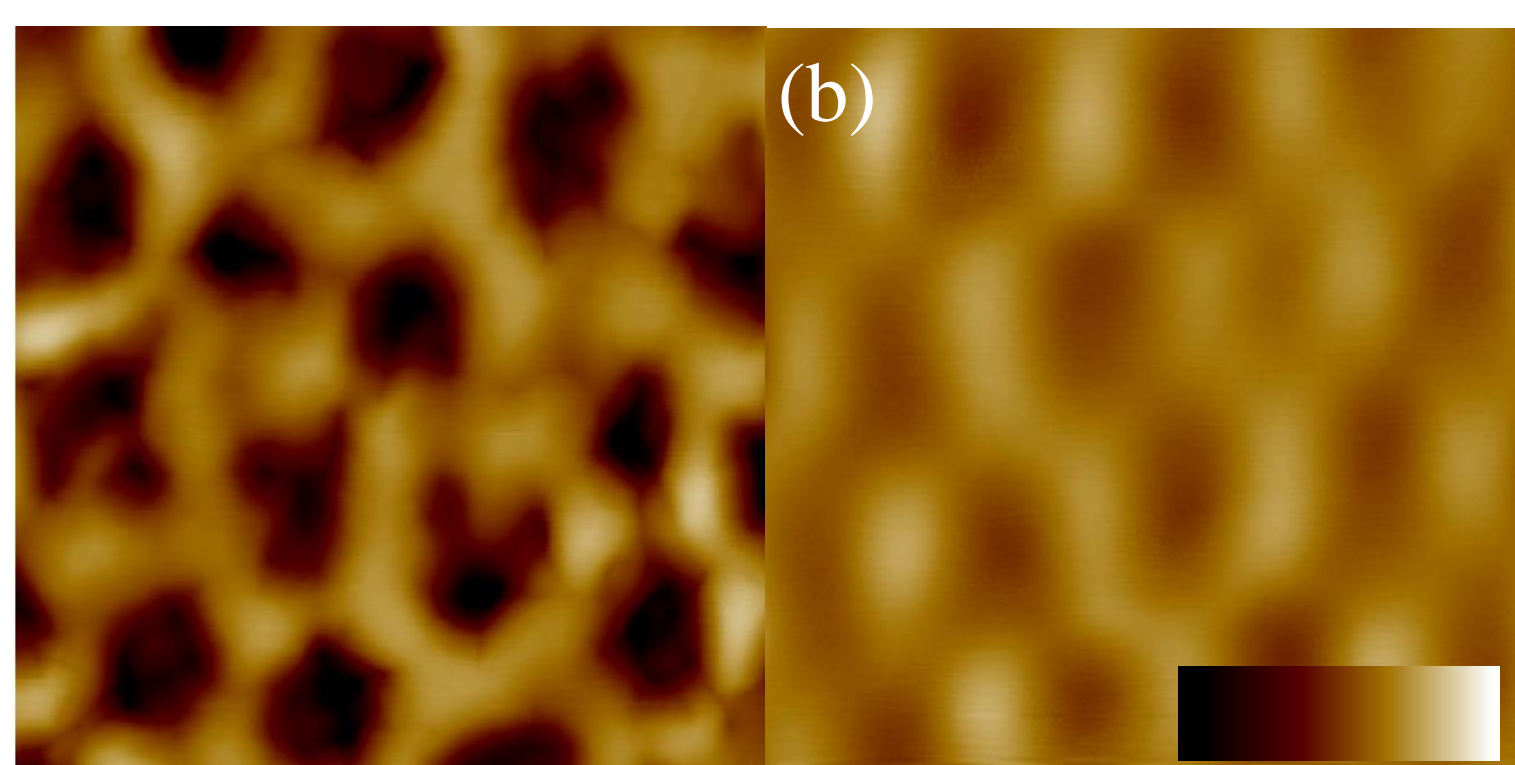


Figure 4. AFM images of samples, which are grown at 150°C (a) and 250°C (b).The scale is from -30nm to 50nm.

Discussion

- The peak on the left is produced by the cL-HH(Ge) transition.
- The peak on the right requires more experiments and testing to determine.

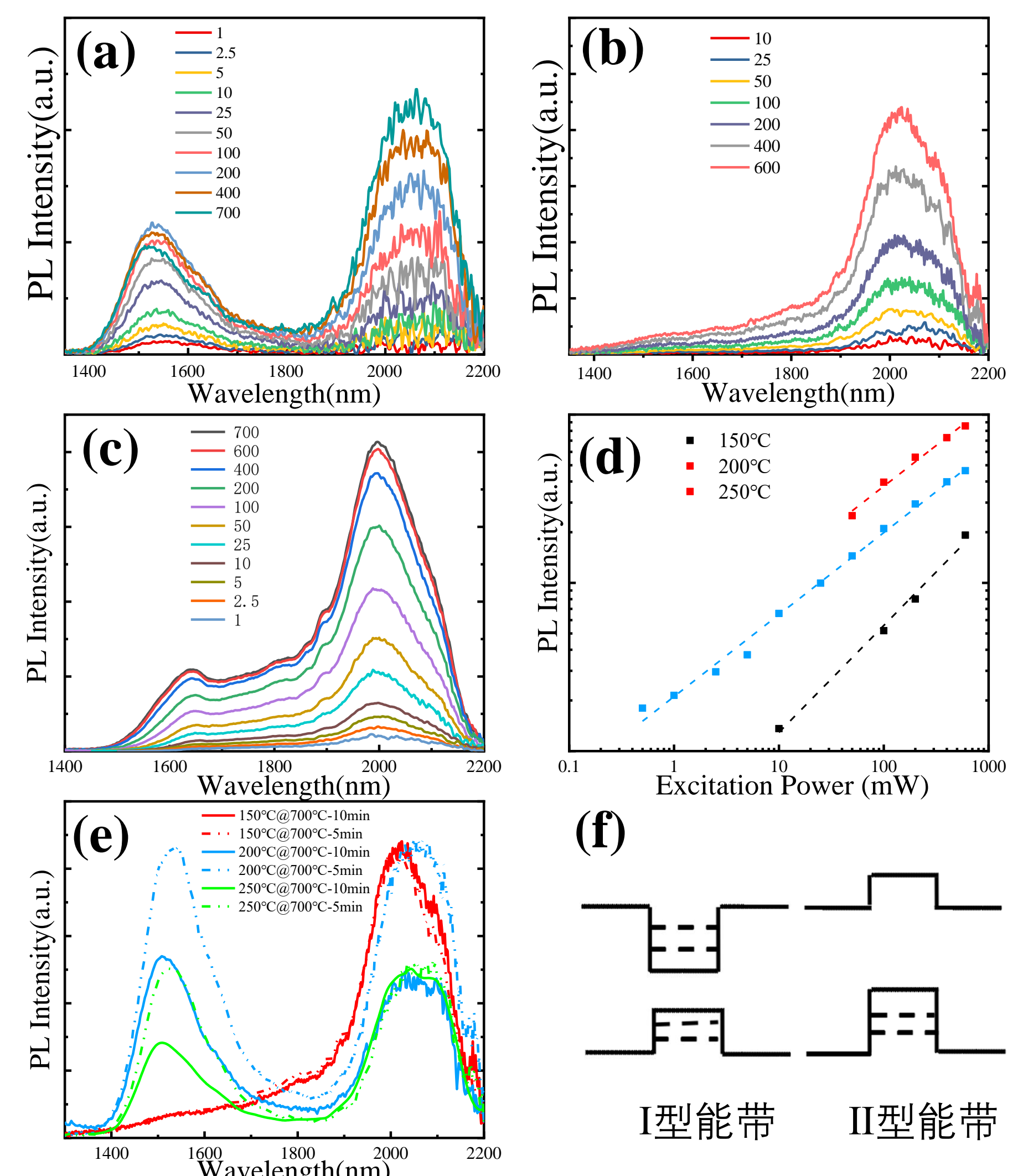


Figure 5. (a)(b) PL of sample grown at 150°C(a), 250°C(b). (c) 20nm Ge films instead of Ge QWs, grown at 200°C. (d) Relationship between luminescence intensity and excitation power. (e) PL spectra of different annealing conditions. (f) Diagram of type I band and type II band, the dashed lines represent the energy levels in the well.

- Effect of microdisk on luminescence performance.

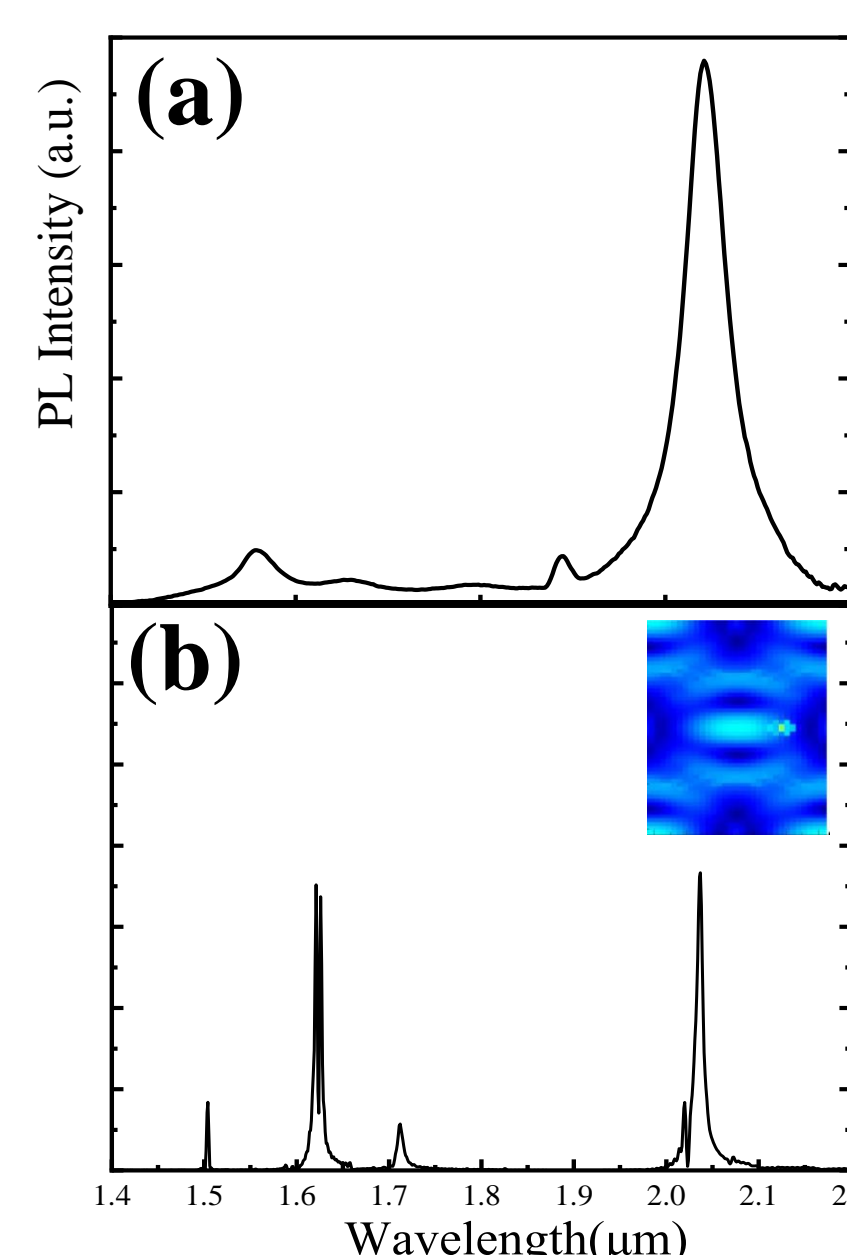


Figure 6. (a) PL spectrum of microdisk grown on 250°C. The microdisk is 1µm in diameter. (b) Simulation of 1µm microdisk by FDTD. The illustration shows the E field distribution of P2. In this structure, there is a significant emission from peak P2 and the opposite from peak P1. This is related to the resonant mode and the peak wavelength. We want to have a strong emission around 1550nm.

Conclusion

- In previous experiments, a small amount of 2H-Ge was observed in low temperature germanium samples. So far, many reports have been made about the preparation of 2H-Ge, but most of them require the introduction of III-V group elements.
- We expect that the direct band gap characteristics of 2H-Ge can be demonstrated at room temperature by means of microdisk mode luminescence.
- For existing samples, more analysis and testing, such as Raman spectroscopy, is needed to analyze the composition and strain. Explore the most appropriate growth parameters